

03-22-2010

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To the Director of the U.S. Patent and Trademark Office: Please record the attached documents or the new address(es) below.

1. Name of conveying party(ies)

Takashi KAITO, Yoshitomo NAKAGAWA,
Junichi TASHIRO, Yasuhiko SUGIYAMA,
Toshiaki FUJII, Kazuo AITA and
Takashi OGAWA

Additional name(s) of conveying party(ies) attached? ☐ Yes ☒ No

3. Nature of conveyance/Execution Date(s):

Execution Date(s) MARCH 12, 2010

- ☒ Assignment ☐ Merger
☐ Security Agreement ☐ Change of Name
☐ Joint Research Agreement
☐ Government Interest Assignment
☐ Executive Order 9424, Confirmatory License
☐ Other _____

2. Name and address of receiving party(ies)

Name: SII NanoTechnology Inc.

Internal Address: _____

Street Address: 8, NAKASE 1-CHOME, MIHAMA-KU

City: CHIBA-SHI, CHIBA

State: _____

Country: JAPAN Zip: 261-8507

Additional name(s) & address(es) attached? ☐ Yes ☒ No

4. Application or patent number(s):

☐ This document is being filed together with a new application.

A. Patent Application No.(s)

12/733,091

B. Patent No.(s)

Additional numbers attached? ☐ Yes ☒ No

5. Name and address to whom correspondence concerning document should be mailed:

Name: BRUCE L. ADAMS, ESQ.

Internal Address: _____

Street Address: ADAMS & WILKS

17 BATTERY PLACE-SUITE 1231

City: NEW YORK

State: NY Zip: 10004

Phone Number: 212-809-3700

Fax Number: 212-809-3704

Email Address: _____

9. Signature:

Signature

BRUCE L. ADAMS
Name of Person Signing

6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 1.21(h) & 3.41) \$ 40.00

- ☐ Authorized to be charged by credit card
☒ Authorized to be charged to deposit account --
any deficiency in enclosed fee
☒ Enclosed
☐ None required (government interest not affecting title)

8. Payment Information

a. Credit Card Last 4 Numbers _____
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b. Deposit Account Number 01-0268

Authorized User Name ADAMS & WILKS

03/19/2010 LMIJELER 00000025 12/33091
01 FC:0021 MARCH 16, 2010

Date

Total number of pages including cover
sheet, attachments, and documents:

4

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Mail Stop Assignment Recordation Services, Director of the USPTO, P.O. Box 1450, Alexandria, V.A. 22313-1450

ASSIGNMENT

WHEREAS, we, Takashi KAITO, Yoshitomo NAKAGAWA, Junichi TASHIRO, Yasuhiko SUGIYAMA, Toshiaki FUJII, Kazuo AITA and Takashi OGAWA, each residing at c/o SII NanoTechnology Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan, have invented new and useful improvements in COMPOSITE FOCUSED ION BEAM DEVICE, PROCESS OBSERVATION METHOD USING THE SAME, AND PROCESSING METHOD, for which we have prepared an application for Letters Patent of the United States of America;

AND WHEREAS, SII NanoTechnology Inc., a Japanese corporation located and doing business at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba 261-8507, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor;

NOW, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to us in hand paid, the receipt of which is hereby acknowledged, we have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said SII NanoTechnology Inc. for the territory of the United States of America, our entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by us on Feb.19,2010;Feb.22,2010; Feb.24,2010;Feb.22,2010;Feb.22,2010;Feb.22,2010; and Feb.19, _____, 2010, respectively, filed February 5, 2010, Application Number 12/733,091 _____, preparatory to obtaining Letters Patent

thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said SII NanoTechnology Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by us had this assignment, sale and transfer not been made.

AND, we hereby covenant and agree that we will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and we hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said SII NanoTechnology Inc. in accordance with this assignment.

Executed this 12th day of March, 2010.

Witness:

Omina Jinbo

Takashi Kaito (L.S.)
Takashi KAITO

Yoshitomo Nakagawa (L.S.)
Yoshitomo NAKAGAWA

Junichi Tashiro (L.S.)
Junichi TASHIRO

Yasuhiko Sugiyama (L.S.)
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Toshiaki FUJII

Kazuo Aita (L.S.)
Kazuo AITA

Takashi Ogawa (L.S.)
Takashi OGAWA